Interfaces near the surface in Fe/Si multilayers studied by grazing-incidence soft-X-ray emission spectroscopy

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Introduction

Penetration depth of X-ray is limited when it is incident at the critical angle of total reflection. Utilizing this property, X-ray fluorescence analysis is used to study the depth profile of a sample in the hard X-ray region. It provides information on the ratio of constituent elements. Grazing-incidence soft-X-ray emission (SXE) spectroscopy thus might be a useful tool to study the chemical bonding state near the surface of multilayers.

Fe/Si multilayers have been widely studied for the strong antiferromagnetic coupling between Fe layers. In the previous study, we made clear that the interdiffused FeSi₂ layer mediates the antiferromagnetic coupling rather than the remained *a*-Si layer [1]. It was also confirmed that SiO₂ was slightly found. However, the site has not been specified. In this study, we applied grazing-incidence SXE spectroscopy to clarify this point.

Experimental

Three Fe (3.0 nm)/Si (*t*) multilayers were prepared, where the thickness *t* of the Si layer was 1.0, 1.3, and 1.5 nm for the respective samples. SXE experiment was carried out at BL-3B using a flat-field type spectrometer. The excitation energy was fixed at 155 eV. The critical angle of total reflection of Fe for E = 155 eV is 76.3°. In this case, penetration depth is estimated to be about 4 nm. The angles of incidence of the excitation light θ we chosen were 60° and 76°.

Results

Figure 1 shows the Si $\overline{L_{2,3} \text{ SXE}}$ spectra measured for the Fe/Si multilayers for $\hat{\theta} = 60^{\circ}$ and 76°, which are indicated with the solid and dotted lines, respectively. It is remarkable that the spectra for $\theta = 76^{\circ}$ have a structure at 94 eV as compared with those for $\theta = 60^{\circ}$. It originates from SiO₂. Effective thickness of each layer was estimated by curve fitting analysis using the SXE spectra for Fe₃Si, FeSi, FeSi₂, a-Si, and SiO₂. The t dependence of the layer thickness concerning the spectra for $\theta = 60^{\circ}$ and 76° is summarized in Figs. 2(a) and 2(b), respectively. The former is concerned with the whole multilayer. The remarkable difference between the two is that the SiO₂ layer is thicker for $\theta = 76^{\circ}$ than for $\theta = 60^{\circ}$ at t = 1.0 and 1.3 nm, while for the Fe₃Si layer the tendency is quite opposite. This is an evidence for the SiO₂ layer to be generated by oxidation of the Fe₃Si layer under the topmost Fe layer. As a result, the topmost Fe₃Si layer reduces in thickness. This result means that the grazing-incidence SXE spectroscopy is quite promising to estimate the bonding state near the surface.

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Fig. 1 Si $L_{2,3}$ SXE spectra measured for the Fe/Si(*t*) multilayers for $\theta = 60^{\circ}$ (solid) and 76° (dotted).



Fig. 2 Plot of the thickness of each layer vs. t concerning the spectra for $\theta = 60^{\circ}$ (a) and 76° (b).

Reference

[1] T. Imazono et al., PF Act. Rep. 2001 Part B 56 (2002).

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